



**ELECTRONIC COPY**

LG806606696  
Report verification at igi.org



June 5, 2026

IGI Report Number **LG806606696**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.47 - 8.52 X 5.34 MM**

**GRADING RESULTS**

Carat Weight **2.41 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

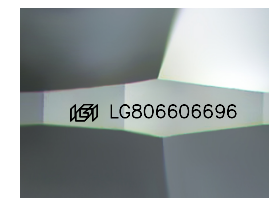
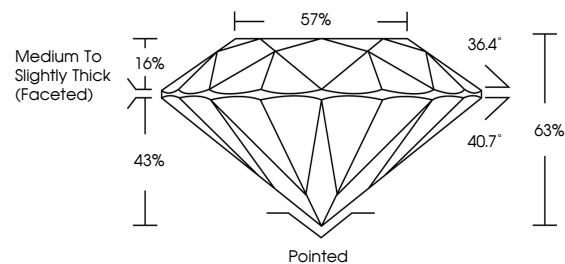
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG806606696**

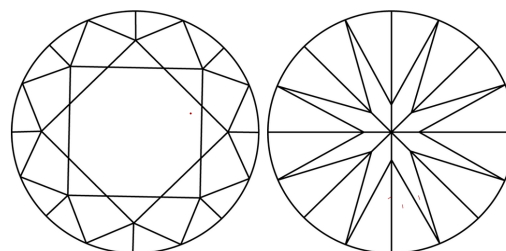
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

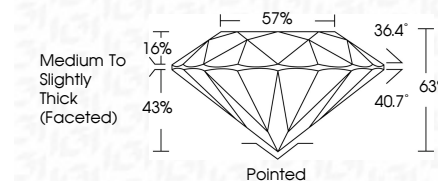
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



June 5, 2026  
IGI Report No. **LG806606696**  
**ROUND BRILLIANT**  
8.47 - 8.52 X 5.34 MM  
2.41 CARATS  
F  
Color Grade  
VS 1  
EXCELLENT  
Depth 43%  
Table 16%  
Girdle 57%  
Medium To Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) LG806606696  
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